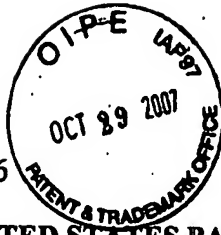


Docket No.: 043890-0746



PATENT

AF
IFD

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Tomohisa TENRA, et al.

RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE

Application No.: 10/537,298

Filed: June 02, 2005

Customer No.: 53080
Confirmation No.: 8367

Group Art Unit: 1772

Examiner: Alexander Thomas

Title: VACUUM HEAT INSULATOR AND ITS MANUFACTURING METHOD

OK. to send
AW

RESPONSE UNDER 37 CFR 1.116

Mail Stop After Final
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This response is filed in response to the Final Office Action dated August 16, 2007.

Remarks begin on page 2 of this paper.